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INFORMATION DISCLOSURE STATEMENT

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U.S. PATENT DOCUMENTS

Examiner Initials	Document Number	Issue or Publication Date	Name	Class	Subclass	Filing Date (If Appropriate)
W	US 2001/0021293	09-13-2001	Kouta, et al.			
W	US 2002/0085824	07-04-2002	Dugan et al.			
W	US 2003/0035640	02-20-2003	Dugan et al.			
W	US 2003/0099452	05-29-2003	Borrelli et al.			
W	6,628,877	09-30-2003	Dugan et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number	Publication Date	Country	Translation Yes	Translation No

OTHER DOCUMENTS

W	Poumellec, "Femtosecond laser irradiation stress induced in pure silica," <i>Optics Express</i> , 11(9):1070-1079 (2003)
W	Schaffer, et al., "Micromachining bulk glass by use of femtosecond laser pulses with nanojoule energy," <i>Optics Letters</i> 26(2):93-95 (2001)

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DATE CONSIDERED:

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